6-20-2012

Controlled Doping of Graphene Using Ultraviolet Irradiation

Zhentang Luo
*Hong Kong University of Science and Technology*

Nicholas J. Pinto
*University of Puerto Rico - Humacao*

Yarely Davila
*University of Puerto Rico - Humacao*

*University of Pennsylvania, cjohnson@physics.upenn.edu*

Follow this and additional works at: [https://repository.upenn.edu/physics_papers](https://repository.upenn.edu/physics_papers)

Part of the Physics Commons

**Recommended Citation**


© 2012 American Institute of Physics. This article may be downloaded for personal use only. Any other use requires prior permission of the author and the American Institute of Physics. The following article appeared in Appl. Phys. Lett. 100, 253108 (2012) and may be found at [http://dx.doi.org/10.1063/1.4729828](http://dx.doi.org/10.1063/1.4729828)

This paper is posted at ScholarlyCommons. [https://repository.upenn.edu/physics_papers/245](https://repository.upenn.edu/physics_papers/245)

For more information, please contact repository@pobox.upenn.edu.
Controlled Doping of Graphene Using Ultraviolet Irradiation

Abstract
The electronic properties of graphene are tunable via doping, making it attractive in low dimensional organic electronics. Common methods of doping graphene, however, adversely affect charge mobility and degrade device performance. We demonstrate a facile shadow mask technique of defining electrodes on graphene grown by chemical vapor deposition (CVD) thereby eliminating the use of detrimental chemicals needed in the corresponding lithographic process. Further, we report on the controlled, effective, and reversible doping of graphene via ultraviolet (UV) irradiation with minimal impact on charge mobility. The change in charge concentration saturates at \(\sim 2 \times 10^{12}\ \text{cm}^{-2}\) and the quantum yield is \(10^{-5}\ \text{e/photon}\) upon initial UV exposure. This simple and controlled strategy opens the possibility of doping wafer-size CVD graphene for diverse applications.

Disciplines
Physics

Comments

© 2012 American Institute of Physics. This article may be downloaded for personal use only. Any other use requires prior permission of the author and the American Institute of Physics. The following article appeared in Appl. Phys. Lett. 100, 253108 (2012) and may be found at http://dx.doi.org/10.1063/1.4729828

This journal article is available at ScholarlyCommons: https://repository.upenn.edu/physics_papers/245
Controlled doping of graphene using ultraviolet irradiation

Zhengtang Luo,1 Nicholas J. Pinto,2 Yarely Davila,2 and A. T. Charlie Johnson3,a)

1Department of Chemical and Biomolecular Engineering, The Hong Kong University of Science and Technology, Clear Water Bay, Hong Kong, China
2Department of Physics and Electronics, University of Puerto Rico at Humacao, Humacao, Puerto Rico 00792, USA
3Department of Physics and Astronomy, University of Pennsylvania, Philadelphia, Pennsylvania 19104-6396, USA

(Received 27 February 2012; accepted 4 June 2012; published online 20 June 2012)

The electronic properties of graphene are tunable via doping, making it attractive in low dimensional organic electronics. Common methods of doping graphene, however, adversely affect charge mobility and degrade device performance. We demonstrate a facile shadow mask technique of defining electrodes on graphene grown by chemical vapor deposition (CVD) thereby eliminating the use of detrimental chemicals needed in the corresponding lithographic process. Further, we report on the controlled, effective, and reversible doping of graphene via ultraviolet (UV) irradiation with minimal impact on charge mobility. The change in charge concentration saturates at \( \sim 2 \times 10^{12} \text{cm}^{-2} \) and the quantum yield is \( \sim 10^{-5} \text{e/photon} \) upon initial UV exposure. This simple and controlled strategy opens the possibility of doping wafer-size CVD graphene for diverse applications. © 2012 American Institute of Physics. [http://dx.doi.org/10.1063/1.4729828]

The exceptionally high room temperature carrier mobility of graphene offers potential for device applications that have attracted enormous interest in the research community. Various methods have been used to tailor the graphene properties for desired applications, including chemical doping,1–3 electrochemical doping,4 and metal contact doping,5 and other metals including bismuth and antimony.6 Reports of conventional chemical doping have relied on strong dopants such as potassium7 and ammonia gas,2 which act as strongly charged impurities and consequently degrade the carrier mobility. It is highly desirable therefore to develop alternative approaches to controlled doping of graphene nanostructures that avoid these effects. Here, we realize controlled doping of graphene grown by chemical vapor deposition (CVD) by exposure to ultraviolet (UV) radiation with minimal impact on the material’s electronic properties, including carrier mobility.

Figure 1(a) is an optical micrograph of a graphene film synthesized by CVD and then transferred onto 300 nm oxide thickness silicon substrate, using a method reported previously.8,9 A typical Raman spectrum (Fig. 1(b)) shows a symmetric and high intensity 2D band at \( \sim 2695 \text{cm}^{-1} \), characteristic of single layer graphene.10 Moreover, the D band (\( \sim 1345 \text{cm}^{-1} \)) intensity, whose relative strength is proportional to disorder in graphitic materials, is only 0%–5% of the G peak (\( \sim 1590 \text{cm}^{-1} \)) intensity, indicating that the graphene material used here is of high quality, as confirmed by electron transport data presented below.

By accurately controlling the growth time and/or position in the furnace, we grew single crystal hexagonal flakes of graphene in random locations with desired size (up to 50 \( \mu \text{m} \)) and areal density.11 In order to avoid sample contamination from polymeric resists,12 contacts were then fabricated to single flakes using a mechanical shadow mask, as follows. A transmission electron microscopy (TEM) sample grid (Electron Microscopy Sciences TVM-Cu, with 150, 200, 300, 400 mesh holes) was carefully placed over a...
graphene flake and slightly fixed to the substrate with silver paint. Electrical contacts (100 nm thick Ag or Au) were then evaporated through the TEM grid shadow mask onto the substrate, and the TEM grid was removed to yield metal electrodes in contact with a pre-selected graphene flake. The electrical properties of the flake could be measured in a three-terminal geometry, with the degenerately doped silicon substrate used as a backgate. The measured device transfer characteristics and mobility (see below) indicate that this method of contact fabrication leaves the graphene in better condition than when conventional lithographic methods are used. The inset to Fig. 1(c) shows a graphene flake that was contacted by two gold electrodes in the manner just described. Future experiments will be directed towards achieving yet more accurate control over the graphene flake size and density to increase the yield of high-quality graphene devices produced with this method.

Figure 1(c) is a plot of the conductance $G$, expressed in units of the conductance quantum $e^2/h$, versus gate voltage ($V_g$) for an as-fabricated CVD graphene device measured under vacuum of 10 mTorr. The $G$-$V_g$ plot shows a typical “V” shape that is characteristic of graphene, with enhanced current in the hole-branch compared to that in the electron-branch; similar observations on exfoliated graphene were attributed to different contact resistances for the different carrier types. From its minimum (the Dirac point), the conductance increases linearly with $V_g$ for both carrier polarities, indicating that the mobility is independent of carrier concentration and type, in agreement with measurements of exfoliated graphene as well for graphene produced by CVD. At gate voltages further from the Dirac point, $G(V_g)$ shows a sub-linear growth, most likely due to the presence of charged impurities or water underneath the graphene flake. Here, the minimum conductivity ($G_{\text{min}}$) and corresponding gate voltage ($V_{g,\text{min}}$) were obtained by extrapolating the linear portion of the $G$-$V_g$ curves. As shown in Fig. 1(c), $G_{\text{min}}$ shows a similar value as exfoliated graphene, of multiple of $4e^2/h$, a well-established universal value for ideal graphene. The fact that $V_{g,\text{min}}$ exhibits a non-zero value, along with the fact that the width of the minimum conductivity region in $V_g$ is broad, indicates the existence of disorder and presence of charge impurities.

A key aspect of the data is that the room temperature hole and electron mobility are found to be large, 3060 and 1630 cm²/V-s, respectively, comparable to values for exfoliated graphene, as well as for graphene produced by CVD. At gate voltages further from the Dirac point, $G(V_g)$ shows a sub-linear growth, most likely due to the presence of charged impurities or water underneath the graphene flake. Here, the minimum conductivity ($G_{\text{min}}$) and corresponding gate voltage ($V_{g,\text{min}}$) were obtained by extrapolating the linear portion of the $G$-$V_g$ curves. As shown in Fig. 1(c), $G_{\text{min}}$ shows a similar value as exfoliated graphene, of multiple of $4e^2/h$, a well-established universal value for ideal graphene. The fact that $V_{g,\text{min}}$ exhibits a non-zero value, along with the fact that the width of the minimum conductivity region in $V_g$ is broad, indicates the existence of disorder and presence of charge impurities.

Figure 2(a) shows $G$-$V_g$ plots for an as-prepared graphene device and for the same device at four different carrier concentration (doping) levels induced by irradiation with UV light ($\lambda = 365$ nm) for progressively longer times, all measured at 295 K and 10 mTorr. Upon UV-doping, the following features are seen: (1) the Dirac point back gate voltage, $V_{g,\text{min}}$, gradually shifts to more negative voltage, indicative of $n$-type doping due to illumination; (2) the shift of the $G$-$V_g$ characteristic is rigid, with almost no change in the minimum conductance or the width of the $V$-shaped curve. We find that the electron mobility is unchanged or even increased while the hole mobility is slightly decreased (both effects are no more than 5% in size); (3) as seen in Fig. 2(b), the UV doping effect shows a saturation behavior at $\sim 2 \times 10^{12}$ e/cm² with a quantum yield of $\sim 10^{-5}$ e/photon upon initial illumination.

These observations show that the carrier addition (doping) induced by UV irradiation leads to no significant change in the carrier scattering rate. The physical rationale for such a phenomenon remains unclear. The observation is similar to what was found for graphene subject to chemical gating by exposure to gas vapors and differs dramatically from the effect of alkali atom dopants like potassium, where the shift in the Dirac point is accompanied by a sharp decrease in mobility. The potassium data were well explained by a picture where ionized potassium ions act as screened Coulomb scattering sites. Theory predicts a conductance that varies linearly with $V_g$, where the slope is proportional to the carrier mobility, which is inversely proportional to the charged impurity density, $n_{\text{imp}}$: $1/\mu \propto n_{\text{imp}}$ for both hole and electron carriers. This behavior is not characteristic of our data, as seen in the inset to Fig. 2(b): $1/\mu$ is essentially constant with doping time, which reflects a change in the carrier density.

The UV doping effect described here is stable under vacuum conditions, slowly reverses when the sample is returned to ambient (timescale of days), and reverses within tens of minutes at elevated temperatures in ambient. The reversible nature of the doping is reflected in Fig. 3, which shows the $G(V_g)$ characteristics for a CVD graphene device
that is first doped by UV irradiation for 16 min, regenerated by annealing at 80 °C for 45 min in ambient, and then UV-doped a second time for 16 min (see inset). All measurements are done at 295 K and 10 mTorr. We observe that curves 1 and 3 are almost identical, indicating that the electronic transport properties of as-fabricated CVD-graphene device are fully recovered by annealing. Re-exposure to UV-irradiation at the same condition leads to a G(Vg) trace identical to that measured after the first doping step (curves 2 and 4). This provides strong evidence that the UV-doping is reversible and reproducible with no significant damage or “poisoning” effect.

The exact doping-de-doping mechanism is not clear at present. Recent work has shown that charge transfer at the substrate interface plays a vital role in the electronic properties of graphene and that this can be tuned by varying the identity of molecules between the silicon substrate and the graphene channel. A shift of the Fermi level, ΔEF, of ~0.35 to 0.09 eV was reported by surface treatment of the substrate, including adding a hydrophobic monolayer between graphene and the silicon substrate, modifying the substrate with silane or polymer molecules with amine or fluorine-containing groups, or trapping water molecular between graphene and the silicon substrate. In the present work, the gradual shift of Dirac point (i.e., Vg,min) to negative gate voltage upon illumination suggests the influence of a similar change in surface charge on the electronic properties of the graphene. Electron trapping adsorbate groups on the graphene surface or graphene-substrate interface (possibly O2− or H2O− derived), a natural consequence of exposure to air, would typically lead to n-type doping as is commonly observed for graphene FET devices, including those presented here. Upon UV exposure, an electron-hole pair is generated that liberates the adsorbates via hole recombination (e.g., h+ + O2− → O2 (gas)) on both sides of CVD graphene, releasing electrons that then contribute toward n-doping (Figures 4(a) and 4(b)). Since this process, unlike chemical doping, does not significantly modify the structure of graphene, one expects only limited effect on the carrier mobility, consistent with our observations.

In conclusion, we have demonstrated a facile shadow mask technique to define electrodes on CVD graphene and report a method to controllably change the carrier concentration in the graphene via UV irradiation. Unlike other doping techniques with strong dopant atoms or molecules, this method was found to have minimal impact on the material’s electronic properties other than the carrier concentration, evidenced by the observation of minimal variation in carrier mobility during the doping and de-doping process. This simple and controlled doping strategy allows tuning the electric properties of wafer-size CVD graphene in defined areas through the use of light absorbing masks and it opens the possibility of diverse applications.

Z.L. and A.T.C.J. were supported by the National Science Foundation through grant DMR-0805136. N.J.P acknowledges support from NSF DMR under grants PREM-0934195 and RUI-0965023. Y.D. gratefully acknowledges the support of the REU program of the Laboratory for Research on the Structure of Matter (NSF REU Site Grant DMR-1062638).


